

Course Schedule, group M19-406**MONDAY**

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|---------------|---|-----|--|------------------|-------|
| 09:20 — 10:05 | ■ | LEC | Computer Technology | 🎓 Krasavin A.V. | 📍 DOT |
| 10:15 — 11:50 | ■ | SEM | Computer Technology | 🎓 Krasavin A.V. | 📍 DOT |
| 14:30 — 16:05 | ■ | LEC | Economics and law in scientific research (2020-09-07 — 2020-10-12) | 🎓 Medvedeva Y.M. | 📍 DOT |
| | ■ | LEC | Economics and law in scientific research (2020-10-19 — 2020-11-23) | 🎓 Medvedeva Y.M. | 📍 DOT |

TUESDAY

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|---------------|---|-----|-----|---|-------|
| 08:30 — 10:05 | ■ | LEC | Opt | Military Training (2020-09-01 — 2020-12-15) | 📍 DOT |
| 10:15 — 16:05 | ■ | SEM | Opt | Military Training (2020-09-01 — 2020-12-15) | 📍 DOT |

WEDNESDAY

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|---------------|---|-----|-------|--|----------------------------------|-------|
| 10:15 — 11:50 | ☑ | LEC | Elect | Television and Space Systems | 🎓 Krasnyuk A.A. | 📍 DOT |
| | ☑ | LEC | Elect | Digital Signal Processing | 🎓 Bocharov Y.I. | 📍 DOT |
| | ☑ | SEM | Elect | Television and Space Systems | 🎓 Krasnyuk A.A. | 📍 DOT |
| | ☑ | SEM | Elect | Digital Signal Processing | 🎓 Bocharov Y.I. | 📍 DOT |
| 12:45 — 13:30 | ■ | LEC | Elect | Nanoelectronics Technologies (2020-09-02 — 2020-10-21) | 🎓 Shaltaeva Y.R. | 📍 DOT |
| | ■ | LEC | Elect | Elements of fault-tolerant systems (2020-09-02 — 2020-10-21) | 🎓 Stenin V.Y. | 📍 DOT |
| | ■ | SEM | Elect | Nanoelectronics Technologies (2020-10-28 — 2020-12-16) | 🎓 Shaltaeva Y.R. | 📍 DOT |
| | ■ | SEM | Elect | Elements of fault-tolerant systems (2020-10-28 — 2020-12-16) | 🎓 Kessarinskiy L.N., Stenin V.Y. | 📍 DOT |
| 13:35 — 15:15 | ■ | SEM | Elect | Nanoelectronics Technologies | 🎓 Shaltaeva Y.R. | 📍 DOT |
| | ■ | SEM | Elect | Elements of fault-tolerant systems | 🎓 Kessarinskiy L.N., Stenin V.Y. | 📍 DOT |

THURSDAY

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|---------------|---|-----|-------|---|-------------------|-------|
| 08:30 — 10:05 | ■ | LEC | Elect | Design of Integrated Circuits and Systems-on-Chip (SOC) (2020-09-03 — 2020-09-24) | 🎓 Bakerenkov A.S. | 📍 DOT |
| | ■ | LEC | Elect | Electronic Systems Design (2020-09-03 — 2020-09-24) | 🎓 Boychenko D.V. | 📍 DOT |
| | ■ | SEM | Elect | Design of Integrated Circuits and Systems-on-Chip (SOC) (2020-10-01 — 2020-12-17) | 🎓 Bakerenkov A.S. | 📍 DOT |
| | ■ | SEM | Elect | Electronic Systems Design (2020-10-01 — 2020-12-17) | 🎓 Boychenko D.V. | 📍 DOT |
| 10:15 — 11:50 | ☑ | LEC | | Principles of nuclear materials science | 📍 DOT | |
| | ☑ | LAB | Elect | Design of Integrated Circuits and Systems-on-Chip (SOC) | 🎓 Bakerenkov A.S. | 📍 DOT |
| | ☑ | LAB | Elect | Electronic Systems Design | 🎓 Boychenko D.V. | 📍 DOT |
| 12:45 — 14:20 | ☑ | LEC | Elect | Reliability and radiation resistance of integrated circuits | 🎓 Zebrev G.I. | 📍 DOT |
| | ☑ | LAB | Elect | Principles of Nuclear Electronics | 🎓 Atkin E.V. | 📍 DOT |
| | ☑ | SEM | Elect | Reliability and radiation resistance of integrated circuits | 🎓 Zebrev G.I. | 📍 DOT |
| | ☑ | SEM | Elect | Principles of Nuclear Electronics | 🎓 Atkin E.V. | 📍 DOT |
| 14:30 — 16:05 | ☑ | LAB | Elect | Reliability and radiation resistance of integrated circuits | 🎓 Zebrev G.I. | 📍 DOT |
| | ☑ | LEC | Elect | Principles of Nuclear Electronics | 🎓 Atkin E.V. | 📍 DOT |

FRIDAY

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|---------------|---|-----|-------|---|-----------------------------------|-------|
| 11:05 — 12:40 | ■ | SEM | Elect | Integrated Microwave Systems | 🎓 Chukov G.V., Elesin V.V. | 📍 DOT |
| | ■ | SEM | Elect | Electromagnetic Compatibility (Emc) | 🎓 Shurenkov V.V. | 📍 DOT |
| 12:45 — 13:30 | ■ | LEC | Elect | Integrated Microwave Systems (2020-09-04 — 2020-10-23) | 🎓 Chukov G.V., Elesin V.V. | 📍 DOT |
| | ■ | LEC | Elect | Electromagnetic Compatibility (Emc) (2020-09-04 — 2020-10-23) | 🎓 Shurenkov V.V. | 📍 DOT |
| 14:30 — 16:05 | ☑ | LAB | Elect | Extreme Electronics (2020-09-04 — 2020-10-16) | 🎓 Yanenko A.V., Skorobogatov P.K. | 📍 DOT |
| | ☑ | LAB | Elect | Elements of micro-and nanoelectronics (2020-09-04 — 2020-10-16) | 🎓 Samotaev N.N. | 📍 DOT |
| | ☑ | LEC | | Principles of Nuclear Technologies | 📍 DOT | |